ABSTRACT OF THE DISCLOSURE

The first embodiment is a support for a lithographic printing plate, wherein the surface area ratios obtained from three-dimensional data by use of an atomic force microscope meets the following requirements (1-i) to (1-iii).

The second embodiment is a support for a lithographic printing plate, wherein the aforementioned surface area ratios and a steepness meets the following requirements (2-i) to (2-ii).

The third embodiment is a support for a lithographic printing plate, wherein the aforementioned surface area ratios meets the following requirements (4-i) to (4-iii).

(1-i) a surface area ratio $\Delta S^{50(50)}$ is 20 to 90%,

(1-ii) a surface area ratio $\Delta S^{50(2-50)}$ is 1 to 30%, and

(1-iii) a surface area ratio $\Delta S^{50(0.2-2)}$ is 5 to 40%,

(2-i) a surface area ratio $\Delta S^{50(50)}$ is 30 to 60%, and

(2-ii) a steepness $a45^{50(0.2-2)}$ is 5 to 40%,

(4-i) a surface area ratio $\Delta S^{5(5)}$ is 20 to 90%,

(4-ii) a surface area ratio $\Delta S^{5(0.2-5)}$ is 5 to 40%, and

(4-iii) A surface area ratio $\Delta S^{5(0.02-0.2)}$ is 15 to 70%.